



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
www.uspto.gov

BIBDATASHEET

Bib Data Sheet

CONFIRMATION NO. 9494

SERIAL NUMBER 10/629,806	FILING DATE 07/30/2003 RULE	CLASS 430	GROUP ART UNIT 1752	ATTORNEY DOCKET NO. 030923
-----------------------------	-----------------------------------	--------------	------------------------	----------------------------------

APPLICANTS

Miwa Kozawa, Kawasaki, JAPAN;

Koji Nozaki, Kawasaki, JAPAN;
Takahisa Namiki, Kawasaki, JAPAN;Junichi Kon, Kawasaki, JAPAN;

** CONTINUING DATA *****

None SJ L

** FOREIGN APPLICATIONS *****

JAPAN 2002-240082 08/21/2002 SJ L

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 03/16/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after o Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 16	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 5
Verified and Acknowledged <i>John H. Lee</i> Examiner's Signature	Initials SJ L				

ADDRESS

38834
 WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP
 1250 CONNECTICUT AVENUE, NW
 SUITE 700
 WASHINGTON, DC
 20036

TITLE

Resist pattern thickening material, process for forming resist pattern, and process for manufacturing semiconductor device

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees (Filing)
<input type="checkbox"/> 1.17 Fees (Processing Ext. of

FILING FEE FEES: Authority has been given in Paper

h e c e e e c e ce e b hee c b